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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re reissue application of: Andrew Perry and Randall Mundt
Patent No.: 6,160,621
Issue Date: December 12, 2000
For: Method and Apparatus for In-Situ Monitoring of
 Plasma Etch and Deposition Processes Using a
 Pulsed Broadband Light Source

Commissioner for Patents
Mail Stop Reissue
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

PRELIMINARY AMENDMENT

In the Claims

Please cancel claims 1, 2, 11, 12, 21, and 22 and amend the following claims: